



Inventor: Garry A. Mercaldi
Title: Low Selectivity Deposition Methods
Assignee: Micron Technology, Inc.
Serial No.: 09/643,004
Filing Date: August 21, 2000
Docket No. MI22-1358


INFORMATION DISCLOSURE STATEMENT
PURSUANT TO 37 C.F.R. §§1.56, 1.97 AND 1.98

In compliance with 37 C.F.R. §§1.56, 1.97 and 1.98, your attention is directed to the U.S. Patents and other documents listed on the attached Form PTO-1449, and copies of which are attached. No admission is made regarding whether the submitted references are prior art.

Citation of these references is respectfully requested.

Respectfully submitted,

Dated: 20 Jul 2004

Attorney: 
James E. Lake
Reg. No. 44,854

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Form PTO 144 U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)		ATTY. DOCKET NO. MI22-1358		SERIAL NO. 09/643,004				
		APPLICANT Garry Mercaldi						
		FILING DATE August 21, 2000		GROUP 2812				
U.S. PATENT DOCUMENTS								
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
	AA	6,458,416	10/2002	Derderian				
	AB	5,597,609	01/1997	Beisswenger et al				
	AC	5,290,824	09/2001	Ishikawa et al				
	AD	6,358,377	03/2002	Schloremberg et al				
	AE	6,627,260	09/2003	Derderian et al				
	AF	5,937,300	08/1999	Sekine et al				
	AG							
	AH							
	AI							
	AJ							
	AK							
	AL							
FOREIGN PATENT DOCUMENTS								
		Document Number	Date	Country	Class	Subclasses	Translation	
							Yes	No
	AM							
	AN							
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)								
	AO							
	AP							
	AQ							
	AR							
EXAMINER					DATE CONSIDERED			
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.								

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